

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of	:	Customer Number: 53080
	:	
Satoshi SHIBATA	:	Confirmation Number: 2300
	:	
Application No.: 10/557,746	:	Group Art Unit: 2813
	:	
Filed: November 21, 2005	:	Examiner: Crawford, Latanya N
	:	
For: MANUFACTURING METHOD OF A SEMICONDUCTOR DEVICE	:	

RESPONSE TO OFFICE ACTION

Mail Stop Amendment
Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Sir:

In response to the Office Action dated April 30, 2008, having a three-month shortened statutory period for response set to expire July 30, 2008, reconsideration of the above-identified application is respectfully requested in view of the following remarks.